

Form 1449*

INFORMATION DISCLOSURE STATEMENT
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Applicant: Leonard Forbes et al.

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Group: 2815

U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
Jee	5,415,126	05/16/1995	Loboda, M.J., et al.	117	88	08/16/93
Jee	5,562,769	10/08/1996	Dreifus, D.L., et al.	117	86	02/22/95
Jee	5,912,837	06/15/1999	Lakhani, V.	365	185.02	10/28/96

FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
Jee	07-226507	08/22/1995	Japan	H01L	29/78	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	
Jee	Suzaki, Y., et al., "Quantum Size Effects of a-Si(:H)/a-SiC(:H) Multilayer Films Prepared by rf Sputtering", <u>Abstracts of Papers Published in the Int. J. Japanese Soc. for Precision Engineering, 28</u> , Abstract of Paper in vol. 60, 182, (June 1994)

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